

# Non-Contact Sheet Resistance Testing for Thin Films and Multi-Layer Systems

# Fields of Application

Thin-Film monitoring of:

- Transparent Conductive Oxides (ITO, ZnO, etc.)
- Metal Nanowires & Meshes
- Graphene
- Carbon Nanotubes
- Metal layers (Al, Mo, Au, etc.)

#### Offers

- Non-contact sheet resistance measurement
- Simultaneous measurement of anisotropy / optical transmission
- Film thickness measurement and monitoring
- Inline-monitoring (ex-vacuo and in-vacuo)
- Detection of deposition inhomogeneities
- Imaging of conductivity-related characteristics

# Characterization of Thin Films

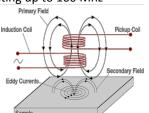
## **Eddy current technology**

Benefits of High Frequency Testing up to 100 Mhz

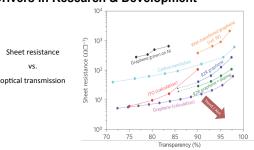
## Signal Amplitude

$$U_{md} = \frac{-d\phi}{t}$$

- + Contact-free
- + High sample rate
- + High sensitivity
- + Measurement of encapsulated layers



#### **Drivers in Research & Development**



S. Bae et al. Nature Nano. 5, 571 (2010); Daniel Neumaier; Proceedings TCO/TCM WS 2013 (201

### Contactless sheet resistance mapping of TCO layers

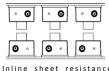




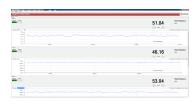
Left: Four-point probe (RM3-AR Jandel) with 100 points manual measurement

Right: Automated Eddy Current C-Scan with EddyCus® TF map 2020SR

## Inline sheet resistance measurement



Inline sheet resistance monitoring with 3 measurement lanes



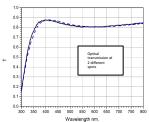
#### **Determination of optical transmission**



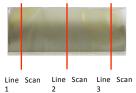


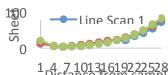


Mapping of structured ITO on

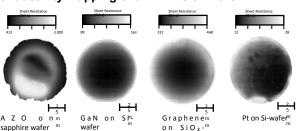


#### Supercapacitor foil

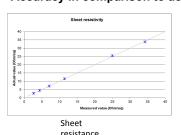


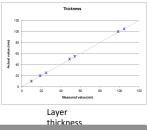


# Conductivity mapping of thin films on wafer



#### Accuracy in comparison to actual values





## Eddy Current Testing Devices for Thin Film and Multi-Layer Systems

"EddyCus® TF map" for automated high resolution

mapping of sheet resistance and layer thickness of

"EddyCus® TF lab" for monitoring sheet resistance and layer thickness of conductive thin films

SIRAGIS

New options:
Optical transmission
Electrical anisotropy



"EddyCus® TF inline" for inline monitoring sheet resistance and layer thickness of conductive thin films



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Certified Quality Management System for development, manufacturing and sales of non-destructive testing

equipment (NDT) in compliance with ISO 9001:2008

TÜV

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